

<b>Notice of References Cited</b>	Application/Control No. 10/779,736	Applicant(s)/Patent Under Reexamination KUO, CHEN LUNG	
	Examiner Wen-Ying P. Chen	Art Unit 2871	Page 1 of 1

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	C	US-2003/0112405	06-2003	Kim et al.	349/156
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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